

In The United States Patent and Trademark Office

<b>In Re Application of:</b>	Hans-Peter Boller
<b>Application No.:</b>	---
<b>Filed:</b>	Concurrently herewith
<b>For:</b>	DOUBLE-DISK POLISHING MACHINE, PARTICULARLY FOR TOOLING SEMICONDUCTOR WAFER
<b>Examiner:</b>	
<b>Group Art Unit:</b>	

Assistant Commissioner for Patents  
Washington, D.C. 20231

Docket No.:H01.2-8984

**CORRESPONDENCE ADDRESS CHANGE**

Please change the Correspondence Address for the above-identified application  
to:

**CUSTOMER NUMBER - 490**

**OR**

VIDAS, ARRETT & STEINKRAUS  
6109 BLUE CIRCLE DRIVE  
SUITE 2000  
MINNETONKA, MN 55343-9131

I am the attorney or agent of record for the above application.

Respectfully submitted,  
VIDAS, ARRETT & STEINKRAUS, P.A.

By:

RICHARD A. ARRETT, ESQ.  
Reg. No. 33,153